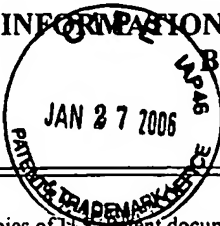


**INFORMATION DISCLOSURE STATEMENT
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First Named Inventor	John L. Klocke
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Examiner Name	Edna Wong

U.S. PATENT DOCUMENTS

Copies of U.S. patent documents do not need to be provided, unless requested by the Patent and Trademark Office. For patents, provide the patent number and the issue date. For published U.S. applications, provide the publication number and the publication date. For unpublished pending patent applications, provide the application number and the filing date.

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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS

Examiner's Initials*	Cite No. (optional)	
22		International Search Report from International Application No. PCT/US04/33229 <i>note</i>
22		Written Opinion from International Application No. PCT/US04/33229 <i>note</i>

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